Electronic Patent Application Fee Transmittal								
Application Number:	10814985							
Filing Date:	31-Mar-2004							
Title of Invention:	Inductively coupled plasma chamber attachable to a processing chamber for analysis of process gases							
First Named Inventor/Applicant Name:	Neal R. Rueger							
Filer:	Terril G. Lewis							
Attorney Docket Number:	102-0102US							
Filed as Large Entity								
Utility Filing Fees								
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)			
Basic Filing:								
Pages:								
Claims:								
Miscellaneous-Filing:								
Petition:								
Patent-Appeals-and-Interference:								
Post-Allowance-and-Post-Issuance:								
Extension-of-Time:								

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)	
Miscellaneous:					
Request for continued examination	1801	1	790	790	
	Tota	Total in USD (\$)			